Serial Number: 09/031,326

Filing Date: February 26, 1998

Title: PARAMETER POPULATION OF CELLS OF A HIERARCHICAL SEMICONDUCTOR STRUCTURE VIA FILE RELATION

## **IN THE SPECIFICATION**

## The paragraph beginning at page 1, line 8 is amended as follows:

The present application is related to the co-filed, co-pending, and co-assigned application entitled "Hierarchical Semiconductor Structure Design," <u>U.S. Serial No. 09/031,398, filed</u>
<u>February 26, 1998, now U.S. Patent No. 6,449,757</u>, which is hereby incorporated by reference.